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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Lill et al.	Group Art Unit: 1762
Application No.: 09/545,110	Examiner: Marianne L. Padgett
Confirmation No.: 9276	Attorney Docket No.: 003117 USA/ETCH/SILICON/JB1
Filing Date: April 6, 2000	August 18, 2004 San Francisco, California
Title: IMPROVED SUBSTRATE MONITORING METHOD AND APPARATUS	

AMENDMENT UNDER 37 C.F.R. § 1.312

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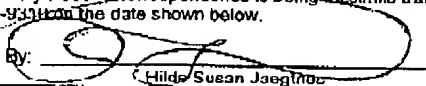
Commissioner for Patents

Examiner Padgett:

This Amendment is filed under 37 CFR 1.312 in response to the Notice of Allowance and Fee(s) Due mailed on May 20, 2004. This amendment is being filed prior to the payment of the issue fee.

I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office via Fax No. (703) 872-9306 on the date shown below.

By:



Hilda Susan Jaegle

Date: August 18, 2004